

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/529,742	SHIHO ET AL.	
Examiner	Art Unit	
Kin-Chan Chen	1765	

	SEARCHED				
Class	Subclass	Date	Examiner		
438	690	1/22/2007	ксс		
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438	692				
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411	41				
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INTERFERENCE SEARCHED				
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(IN	SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
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